

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method for H2 Recycling In Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
Examiner: Olivia T. Luk Group Art Unit: 2812
Docket No.: M-8608US

7
9/12/02
Jum
RECEIVED
SEP - 9 2002
TECHNICAL CENTER 2800

Irvine, California
August 21, 2002

BOX AMENDMENT
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

RESPONSE TO NOTICE OF RESTRICTION REQUIREMENT

Dear Sir:


In response to the Restriction Requirement dated June 27, 2002, Applicant(s) hereby elect to prosecute Group I, Claims 1-7. Applicant reserves the right to prosecute non-elected Claims 8-15, in a divisional application. If the Examiner has any questions, please call the undersigned at (949) 752-7040.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on August 21, 2002.


Sandy Kim

August 21, 2002
Date of Signature

Respectfully submitted,


Theodore P. Lopez
Attorney for Applicant(s)
Reg. No. 44,881

LAW OFFICES OF
MACPHERSON, KWOK CHIEN
& HEID LLP

2402 MICHELSON DRIVE
SUITE 210
IRVINE, CA 92612
(949) 752-7040
FAX (949) 752-7049